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	Application No.	Applicant(s)	
Notice of Allowability	10/660.681	MOROHOSHI, HIROSHI	
	Examiner	Art Unit	
	Alan A. Mathews	2851	
The MAILING DATE of this communication appeall claims being allowable, PROSECUTION ON THE MERITS IS nerewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RID of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject to and MPEP 1308.	plication. If not included n will be mailed in due course. T	
1. X This communication is responsive to communication filed 1	<u>12-22-05</u> .		
2. X The allowed claim(s) is/are <u>9-16</u> .			
 3. Acknowledgment is made of a claim for foreign priority unally as a last of the priority documents have a last of the priority documents have a last of the priority documents have a last of the certified copies of the priority documents have a last of the priority documents have a last of the certified copies of the priority documents have a last of the certified copies of the priority documents have a last of the priority documents have a last of the certified copies of the priority documents have a last of the last	e been received. e been received in Application No		the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirement	ts
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give			F
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) I including changes required by the Notice of Draftspers	son's Patent Drawing Review (PTO	-948) attached	
1) hereto or 2) to Paper No./Mail Date	•		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the (Office action of	
Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the	• ••	•	
5. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			
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Attachment(s)	5 □ Nation of Left control 5	D-1 1 A 1' 1' (DTO 450)	
 I. ☐ Notice of References Cited (PTO-892) I. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 	 5. ☐ Notice of Informal F 6. ☐ Interview Summary 	Patent Application (PTO-152)	
	Paper No./Mail Da	tè	
B. [_] Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	98), 7. ⊠ Examiner's A mend	ment/Comment	
I. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. X Examiner's Statement	ent of Reasons for Allowance	
	9. Other	Can a. qualle	r Eren
	A	lan A. Mathews	,
	Pr	imary Examiner	

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EXAMINER'S COMMENT

1. The substitute specification filed December 22, 2005, has been entered.

REASONS FOR ALLOWANCE

2. The following is an examiner's statement of reasons for allowance:

The prior art does not disclose or suggest the step of calculating a Zernike sensitivity coefficient that represents sensitivity of a change of image quality of the predetermined pattern to a change of Zernike coefficient, when wave front aberration in the projection optical system is developed into a Zernike polynomial for all divided point light sources and determining an effective light source distribution based on a combination of Zernike sensitivity coefficient of all the divided point light sources in combination with all the other steps recited in independent claim 9.

The prior art does not disclose or suggest a controller for forming the effective light source shape based on a combination of Zernike sensitivity coefficients that represents sensitivity of a change of image quality of the predetermined pattern to a change of a Zernike coefficient, when wave front aberration in the projection optical system is developed into a Zernike polynomial for plural point light sources that divide an effective

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light source area for illuminating the mask by intensity of each point light source in combination with all the other elements recited in independent claim 13.

The prior art does not disclose or suggest said database indicating a combination of a Zernike sensitivity coefficient that represents sensitivity of a change of image quality of the predetermined pattern to a change of a Zernike coefficient, when wave front aberration in the projection optical system is developed into a Zernike polynomial for plural point light sources that divide an effective light source area for illuminating the mask by intensity of each point light source in combination with all the other recitations in independent claim 14.

The prior art does not disclose or suggest calculating a Zernike sensitivity coefficient that represents sensitivity of a change of image quality of the predetermined pattern to change of a Zernike coefficient, when wave front aberration in the projection optical system is developed into a Zernike polynomial for all divided point light sources; determining an effective light source distribution based on a combination of Zernike sensitivity coefficient of all divided point light sources; and forming the effective light source distribution by intensity of each point light source in combination with all the other recitations in independent claim 15.

The prior art does not disclose or suggest a controller for forming the effective light source shape based on a combination of a Zernike sensitivity coefficient that represents Application/Control Number: 10/660,681

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sensitivity of a change of image quality of the predetermined pattern to a change of a Zernike coefficient, when wave front aberration in the projection optical system is developed into a Zernike polynomial for plural point light sources that divide an effective light source area for illuminating the mask by intensity of each point light source in combination with all the other recitations in independent claim 16.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alan A. Mathews whose telephone number is (571) 272-2123. The examiner can normally be reached on Monday through Friday from 8:00 AM to 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on (571) 272-2258. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Alan A. Mathews Primary Examiner

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